## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of: Docket No.: 4240-104-RCE2 Applicants: JUNG, Hee Tae, et al. Conf. No.: 9621 1639 Application No.: 10/805,044 Art Unit: Date Filed: March 19, 2004 Examiner: Christopher M. Gross Title: METHOD FOR Customer No.: FABRICATING A BIOCHIP USING THE HIGH DENSITY 23448

## CERTIFICATE OF EFS FILING

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Thereby certify that this document is being filed via EFS in the United States Patent and Trademark Office on September 16, 2010.

//kelly k. reynolds/

## RESPONSE TO MARCH 17, 2010 FINAL OFFICE ACTION, PETITION FOR EXTENSION OF TIME AND REQUEST FOR CONTINUED EXAMINATION IN U.S. PATENT APPLICATION NO. 10805.044

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

This responds to the March 17, 2010 Final Office Action in the above-identified application. The time for responding to the March 17, 2010 Office Action without extension was set at three months, or September 17, 2010. Applicants hereby request a three month extension of time under 37 CFR § 1.136 to extend the deadline for response to September 17, 2010. This response is therefore timely.

Remarks concerning the amendments to the claims and the substance of the August 10, 2009 Office Action are set out in the Remarks section below.